INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 23, 2026

IGI Report Number	LG839696494
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.13 - 8.17 X 4.88 MM

GRADING RESULTS

Carat Weight	2.04 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	VERY GOOD

ADDITIONAL GRADING INFORMATION

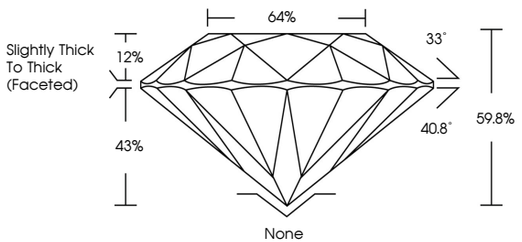
Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG839696494

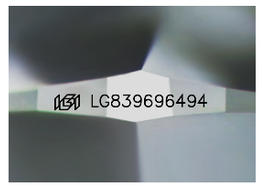
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG839696494

Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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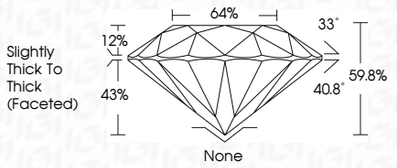

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ROUND BRILLIANT
8.13 - 8.17 X 4.88 MM
Carat Weight 2.04 CARATS
Color Grade E
Clarity Grade VS 1
Cut Grade VERY GOOD
Depth 59.8%
Table 64%
Girdle Slightly Thick To Thick (Faceted)
Culet None
Polish EXCELLENT
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) IGI LG839696494
Comments:
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Type IIa